

Notice of References Cited	Application/Control No. 10/812,960	Applicant(s)/Patent Under Reexamination WU, CHIH-KANG	
	Examiner Jason M. Han	Art Unit 2875	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
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	G	US-			
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	K	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP2001283624A	10-2001	Japan	Hirashiro et al.	F21V 008/00
	O					
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	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Kuodou:KK, English Translation of HIRASHIRO (JP 2001-283624), 10-2001, http://www19.ipdl.ncipi.go.jp/PA1/result/detail/main/wAAAPMa40IDA413283624P1.htm , Abstract pp. 1-2, Description pp. 1-7, Drawings pp.1-3
	V	
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